Inventor Information

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Application Information

Title Line One:: METHOD FOR ASSESSING IRRADIATION
Title Line Two:: INTENSITY OF A LASER BEAM, AN
Title Line Three:: APPARATUS FOR ASSESSING IRRADIATION
Title Line Four:: INTENSITY USED UNDER THIS METHOD,
Title Line Five:: AND A LASER BEAM IRRADIATION SYSTEM
Total Drawing Sheets:: 8
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Prior Foreign Applications

Foreign Application One:: 2001-55771

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Assignee Information

Name of assignee::
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